

## United States Patent and Trademark Office



UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address COMMISSIONER FOR PATENTS P.O. Box 1439 Alexandra, Vignia 22313-1450 www.napto.gov

DATH MAILED: 10/24/2003

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/838,717	04/19/2001	Glen P. Gilfeather	AMDA.516PA	8808
1	7590 10/24/2003		EXAMINER	
CRAWFORD PLLC 1270 Northland Drive, Suite 390			NGUYEN, TU T	
St. Paul, MN 55120			ART UNIT	PAPER NUMBER
			2877	

Please find below and/or attached an Office communication concerning this application or proceeding.

·	Application No.	Applicant(s)			
Office Action Summary	09/838,717	GILFEATHER ET AL.			
Office Action Summary	Examiner	Art Unit			
	Tu T. Nguyen	2877			
The MAILING DATE of this communication app ars on the cover sheet with the correspondence address Period for Reply					
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Estimations of time may be available under the provisions of 37 CPR 1.35(a). In no event, however, may a reply be timely filled after 51X (0) MONTH'S from the maining date of this communication.  - If the predict of reply is applicated above, the maximum statutory period will apply and will be considered timely.  - If NO period for reply is applicated above, the maximum statutory period will apply and will applicate (in MONTH'S from the mailing date of filts communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S. C. § 133).  - Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any searned patent term adjustment. See 37 CFR 1.704(b).					
Responsive to communication(s) filed on					
2a) ☐ This action is <b>FINAL</b> . 2b) ☑ Thi	s action is non-final.				
3) Since this application is in condition for allowance except for formal matters, prosecution as to the ments is					
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213. <b>Disposition of Claims</b>					
4)⊠ Claim(s) 1-19 is/are pending in the application.					
4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.					
6)⊠ Claim(s) <u>1-19</u> is/are rejected.					
7) Claim(s) is/are objected to.					
8) Claim(s) are subject to restriction and/or election requirement.					
Application Papers					
9)☐ The specification is objected to by the Examiner.					
10) The drawing(s) filed on is/are: a) accept	ted or b) objected to by the Ex	aminer.			
Applicant may not request that any objection to the	•				
11) ☐ The proposed drawing correction filed on is: a) ☐ approved b) ☐ disapproved by the Examiner.					
If approved, corrected drawings are required in reply to this Office action.					
12)☐ The oath or declaration is objected to by the Examiner.					
Priority under 35 U.S.C. §§ 119 and 120					
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).					
a) ☐ All b) ☐ Some * c) ☐ None of:					
<ol> <li>Certified copies of the priority documents have been received.</li> </ol>					
2. Certified copies of the priority documents have been received in Application No					
<ul> <li>Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 1.7.2(a)).</li> <li>See the attached detailed Office action for a list of the certified copies not received.</li> </ul>					
14) ☑ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).					
a) The translation of the foreign language provisional application has been received.					
15)☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.					
Attachment(s)					
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s)		ary (PTO-413) Paper No(s) Il Patent Application (PTO-152)			

Serial Number: 09/838,717 Filing Date: 04/19/01

## Detailed Office Action

## Claim Rejections - 35 U.S.C. § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kino et al (4,683,750) in view of Eriguchi (6,395,563).

With respect to claims 1,14, Kino discloses a system for analyzing semiconductor dies (column 9, lines 1-10). The system comprises: a laser beam for perturbing the die, analyzing the thermal of the bond of the die (column 9, lines 1-10).

Kino does not disclose a semiconductor analysis arrangement and a fiber cable to direct light from the laser to the die. Eriguchi discloses a semiconductor analysis arrangement 5 (fig 2) for holding a semiconductor 22 (fig 2) and a fiber cable 11 (fig 2) for transmitting the laser to the semiconductor. It would have been obvious to modify Kino's system with Eriguchi to facilitate the testing.

With respect to claims 2,17, Eriguchi discloses a light direction arrangement 24 (fig 2).

With respect to claims 3,16, Kino discloses a laser source (column 9, line 4).

With respect to claim 4, Eriguchi discloses a fixture 21 (fig 16) for holding the semiconductor die.

With respect to claim 5, the claimed arrangement for evacuating a chamber would have been known. It would have been obvious to modify Eriguchi with a system for evacuating the chamber to make the system more efficient.

With respect to claim 6, Eriguchi discloses a light source 8 (fig 1) located outside the test chamber 5 (fig 1).

With respect to claims 7-8, Eriguchi discloses a controller 13 (fig 1). However, Eriguchi does not explicitly disclose a computer. Using a computer as a controller would have been known. It would have been obvious to use a known computer as a controller to control the system faster.

With respect to claim 9, Eriguchi does not disclose a protective fiber optic waveguide. However, using a protective fiber optic waveguide to protect the fiber would have been known. It would have been obvious to use the known protective waveguide to protect the fiber from damage.

With respect to claim 10, Eriguchi discloses a fiber 11 (fig 1) for directing the light to the die.

With respect to claims 11-12, Eriguchi discloses a detector 9 (fig 1) to detect the defect of the wafer.

With respect to claim 13, Kino discloses a perturbation device (column 9, line 4) and Eriguchi discloses a system for detecting the wafer. It would have been obvious to modify Kino with Eriguchi to facilitate the testing.

With respect to claim 15, refer to discussion in claim 1 above for the system and refer to discussion in claim 13 above for the perturbation device.

With respect to claim 18, Eriguchi does not explicitly disclose detecting the cause of a failure of the die. However, the skill in the art would have been motivated to modify Eriguchi to detecting the cause of the failure to fix the problem easier.

With respect to claim 19, Eriguchi does not disclose a vacuum chamber. However, using a vacuum chamber for analyzing a wafer would have been known. It would have been obvious to modify Eriguchi with the known vacuum chamber to enhance the testing.

## Response to Arguments

Applicant's arguments with respect to claims 1-19 have been considered but are moot in view of the new ground(s) of rejection.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tu T Nguyen whose telephone number is (703) 306-9185. The examiner can normally be reached on M-T 7:30-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Frank G Font can be reached on (703) 308-4881. The fax phone number for the organization

where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Tu T. Nguyen Primary Examiner Group Art Unit 2877

10/14/03